



Elettra Sincrotrone Trieste



UNIVERSITÀ  
DEGLI STUDI  
DI TRIESTE

# Gain, noise, and collection efficiency of GaAs SAM-APDs with staircase structure by means of synchrotron radiation

Colja M.<sup>\*,1</sup>, Cautero M.<sup>1</sup>, Steinhartová T.<sup>2,8</sup>, Pilotto A.<sup>3,6</sup>, Antonelli M.<sup>4</sup>, Cautero G.<sup>4,5</sup>, Menk R. H.<sup>4,5,7</sup>, Arfelli F.<sup>4,9</sup>, Dal Zilio S.<sup>2</sup>, Biasiol G.<sup>2</sup>, Gianoncelli A.<sup>5</sup>, Bonanni V.<sup>5</sup>, Palestri P.<sup>3</sup>, Driussi F.<sup>3</sup>

<sup>1</sup> DIA, University of Trieste, 34127 Trieste, Italy

<sup>2</sup> IOM CNR, Laboratorio TASC, Area Science Park Basovizza, 34149 Trieste, Italy

<sup>3</sup> DPIA, University of Udine, Udine, Italy

<sup>4</sup> INFN-Trieste, Padriciano, Trieste, Italy

<sup>5</sup> Elettra Sincrotrone Trieste S.C.p.A., Area Science Park Basovizza, 34149 Trieste, Italy

<sup>6</sup> C2N, Université Paris-Saclay, 10 Boulevard Thomas Gobert, 91120 Palaiseau, France

<sup>7</sup> Department of Medical Imaging, University of Saskatchewan, Saskatoon, Canada SK S7N 5A2

<sup>8</sup> Infineon Technologies, Siemensstraße 2, 9500 Villach, Austria 9. DF, University of Trieste, 34127 Trieste, Italy

matija.colja@elettra.eu

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# Introduction

- increasing demand for fast and efficient X-ray detectors
- silicon-based detectors widely employed, but are not efficient in hard X-ray range



research of new materials  
(Ge, compound semiconductors, ...)

- we are developing

**GaAs SAM-APDs  
with staircase structure**



# GaAs SAM-APDs with staircase structure

## Why GaAs?

	<b>Si</b>	<b>Ge</b>	<b>GaAs</b>	
density [g/cm <sup>3</sup> ]	2.33	5.323	5.32	→ shorter attenuation length
effective atomic number	14	32	32	
electric-breakdown field [V/cm]	3×10 <sup>5</sup>	1×10 <sup>5</sup>	4×10 <sup>5</sup>	
electron mobility [cm <sup>2</sup> /Vs]	1350	3900	8000	→ shorter response time
band-gap [eV]	1.12	0.66	1.42	→ possibility to operate at room temperature

# Why avalanche?

low fluxes / single photon detection



very weak signals (thousands of electrons)



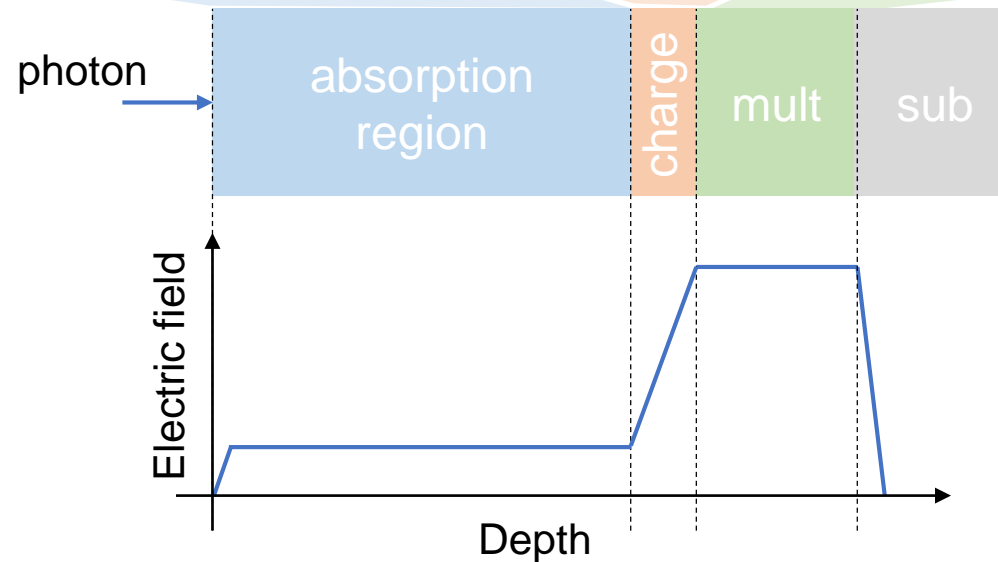
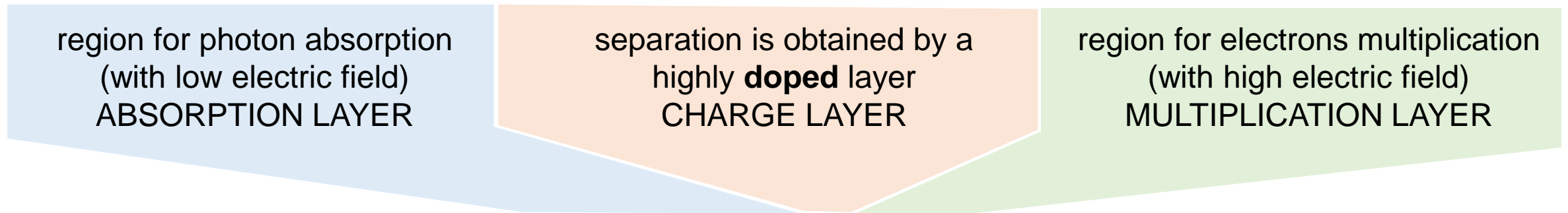
need for amplification



impact ionization = internal amplification

# Why Separate Absorption and Multiplication?

photon absorption in a region with a high electric field = noise contribution



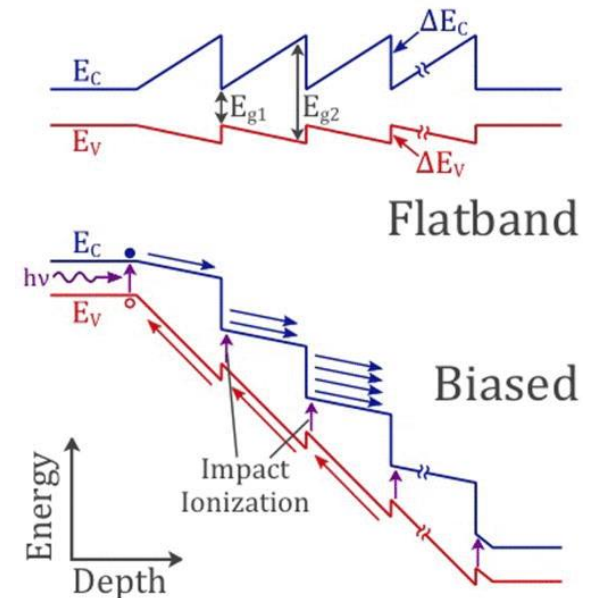
# GaAs SAM-APDs with staircase structure

## Why staircase structure?

multiplication in a region with similar electron/hole ionization coefficients  
=  
noise contribution

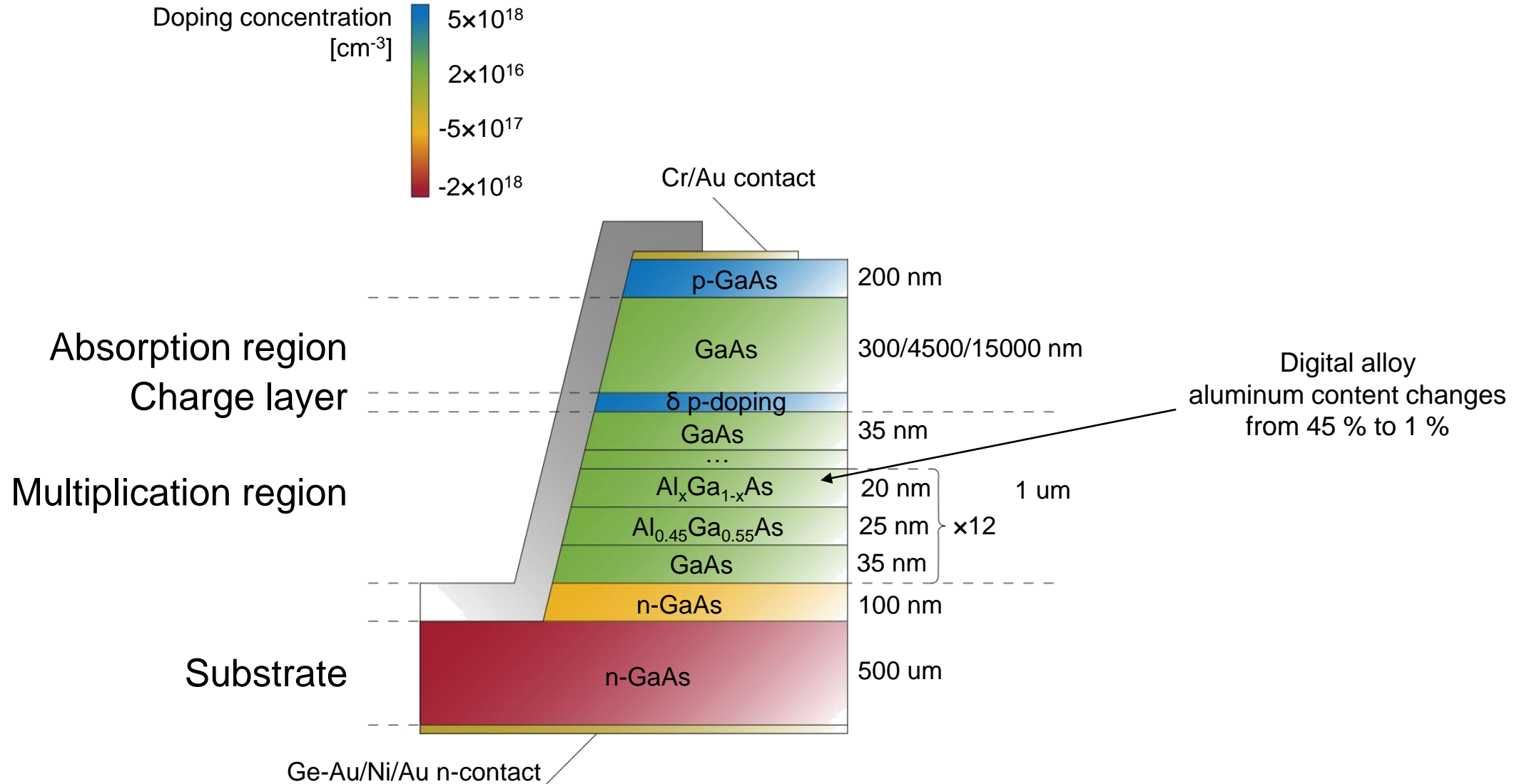
- $\alpha/\beta_{\text{GaAs}} \cong 1 \rightarrow$  high noise 😞
- to reduce noise: band-gap engineering

↓  
staircase structure  
(impact ionization of electrons  
at discrete locations)

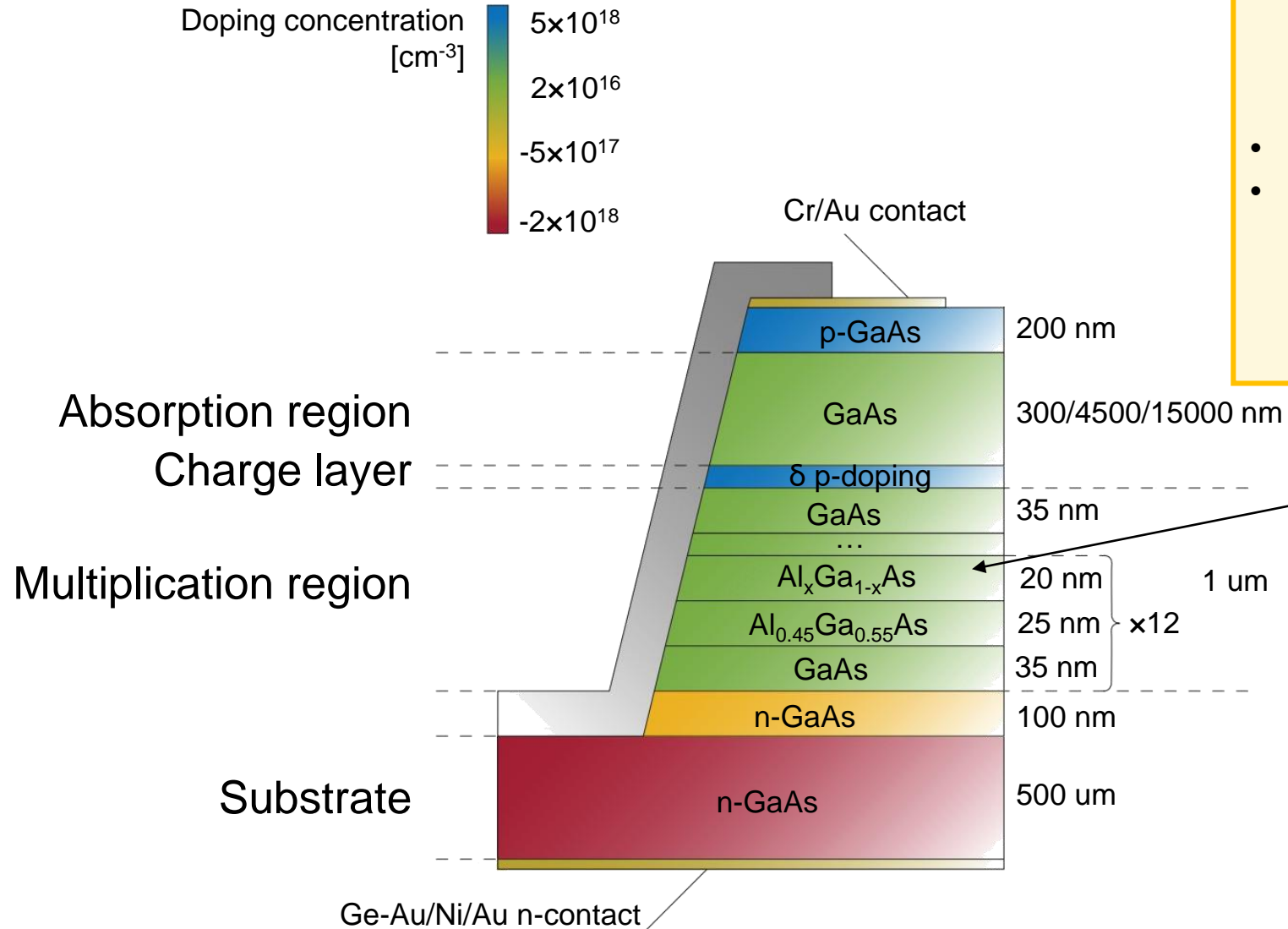


[David, J. The staircase photodiode.  
*Nature Photon* **10**, 364–366 (2016)]

# The detector – cross section



# The detector – cross section



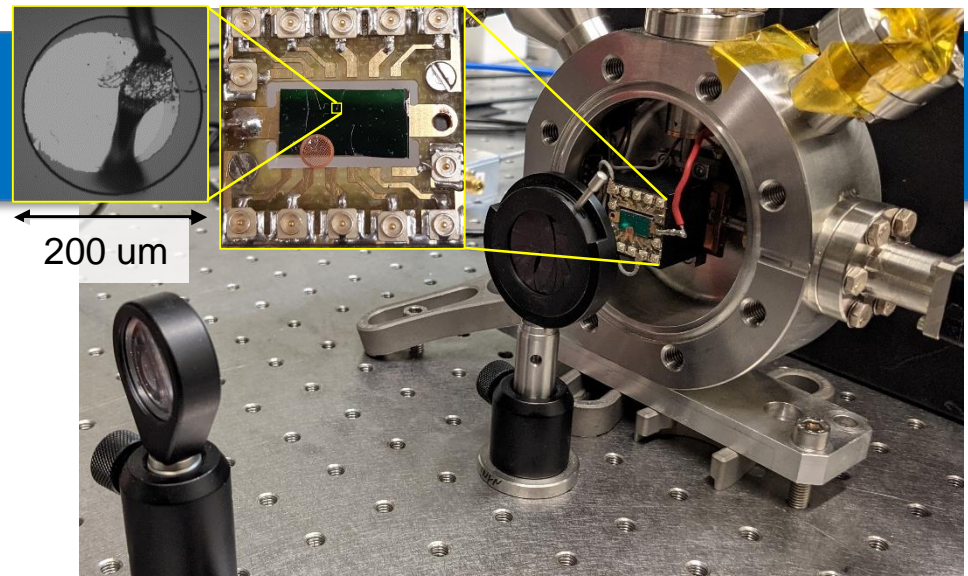
## PROTOTYPES

- not sufficiently thick for hard X-rays
- expressly developed to investigate recombination in:
  - metal-semiconductor interface
  - absorption region

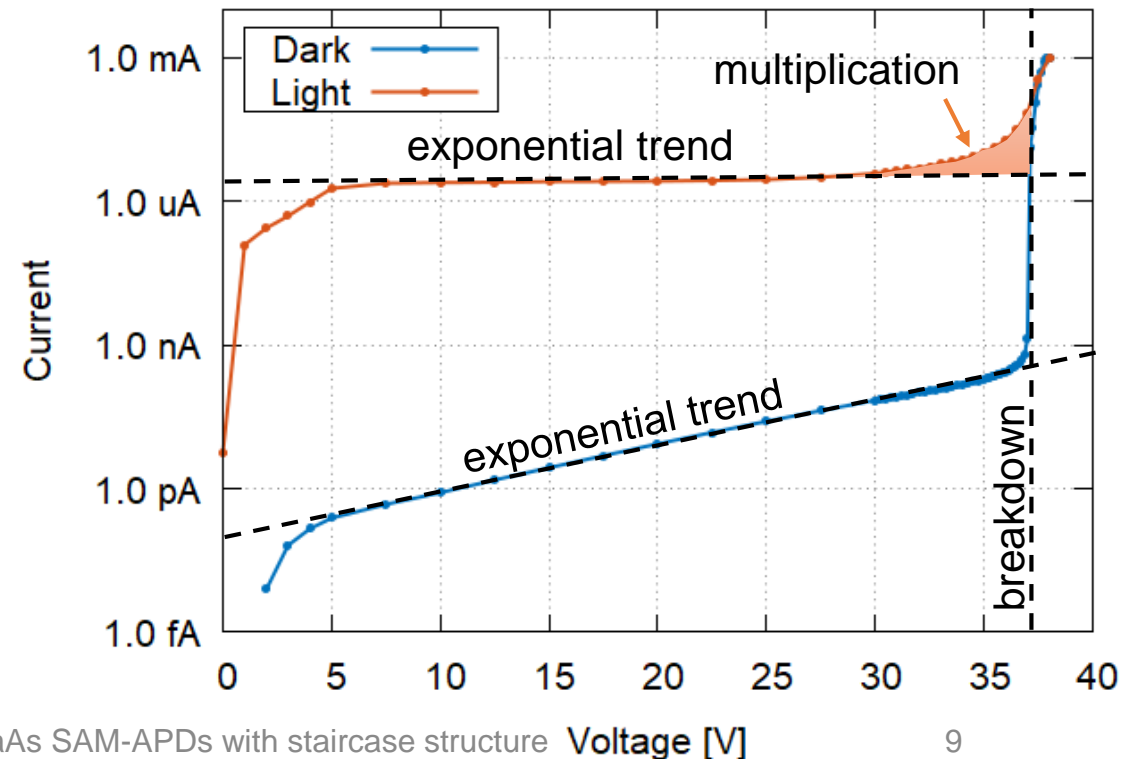
Digital alloy  
aluminum content changes  
from 45 % to 1 %



# Characterization with laser



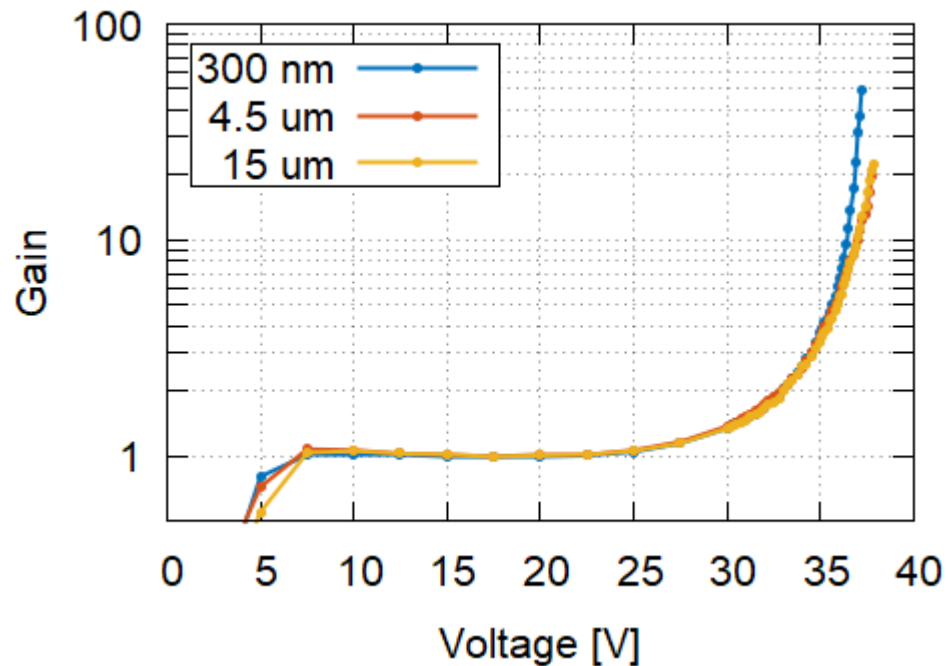
- $E_{ph} = 2.33 \text{ eV}$  →
  - single e/h pair production
  - no photogeneration in the multiplication layer
- initial exponential current growth due to lowering of the charge layer potential barrier
- $V_{\text{breakdown}} = 37 \text{ V}$
- multiplication from 25 V to breakdown



# Gain

$$M(V) = \frac{I_m^{ph}(V) - I_m^{dark}(V)}{a \cdot e^{b \cdot V}}$$

- $a$  and  $b$  are extracted from I-V measurements interpolating the initial exponential growth
- $M_{max} = 50$

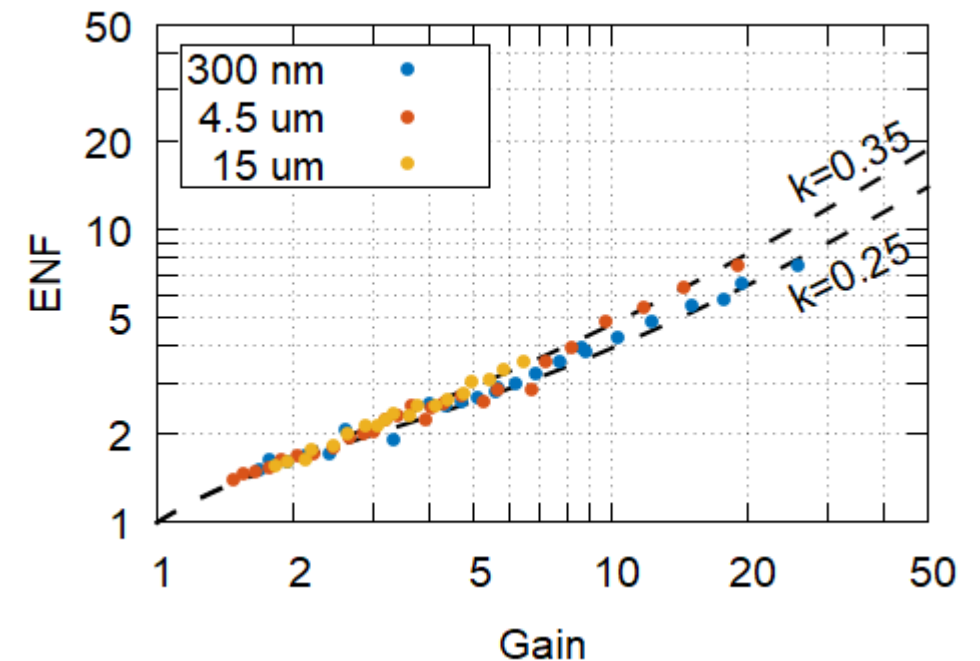


# Excess Noise Factor

$$ENF = \frac{S_i \cdot B}{M^2 \cdot 2q I_{ph} \cdot B}$$

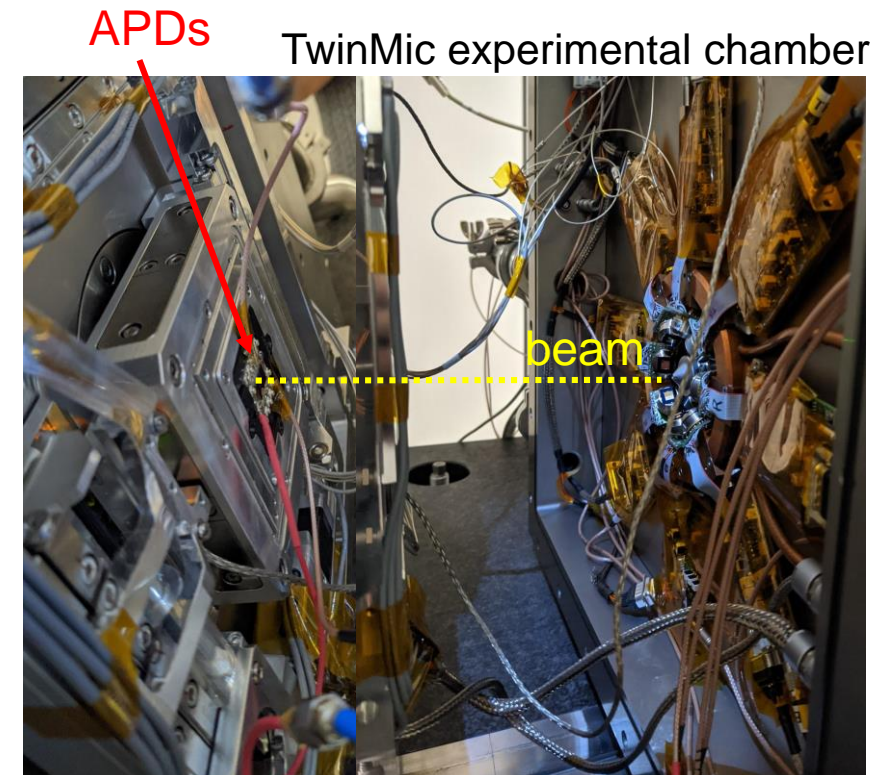
- $S_i$ : measured current spectral density
- $I_{ph}$ : DC value of photo-current with  $M = 1$
- $B$ : system bandwidth

- $\alpha/\beta = k \in [0.25, 0.35]$



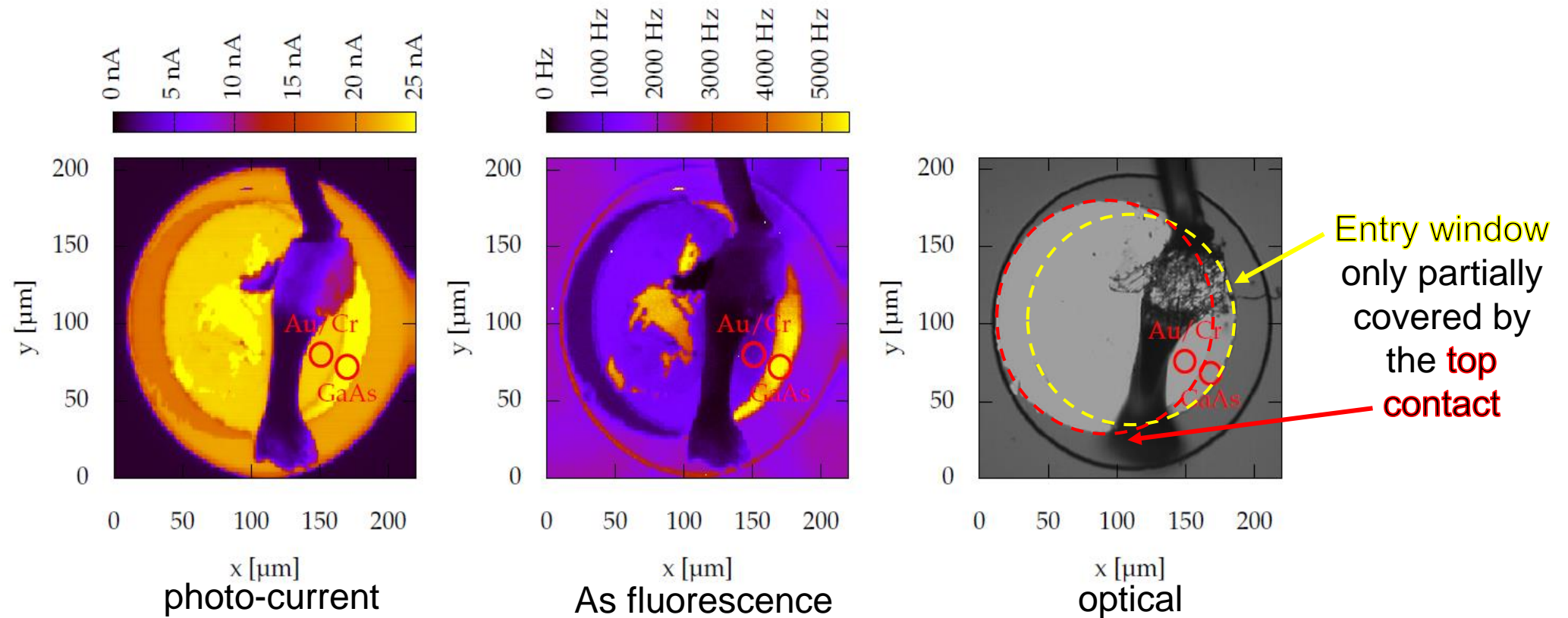
# Synchrotron radiation measurements

- investigation of recombination in:
  - metal-semiconductor interface
  - absorption region
- TwinMic beamline (Elettra Sincrotrone)
  - photon energies = [400 eV, 2200 eV]
  - sub-micrometric monochromatic beam



# Metal-semiconductor interface (1)

- chemical characterisation (As fluorescence)
- identification of areas not covered by top contact



# Metal-semiconductor interface (2)

- current measured when the radiation entered:

Energy [eV]	through Cr/Au	directly in GaAs		
	$I_m^{Au}$ [nA]	$I_m^{GaAs}$ [nA]	$T_m$ [%]	$T_{th}$ [%]
940	$64.187 \pm 0.025$	$119.793 \pm 0.025$	$53.58 \pm 0.02$	$51.8 \pm 0.3$
1090	$81.903 \pm 0.025$	$125.670 \pm 0.025$	$65.17 \pm 0.02$	$62.0 \pm 0.3$
1500	$232.192 \pm 0.025$	$318.681 \pm 0.025$	$72.86 \pm 0.01$	$79.3 \pm 0.2$
1705	$293.290 \pm 0.025$	$378.027 \pm 0.025$	$77.58 \pm 0.01$	$84.6 \pm 0.1$
2010	$278.579 \pm 0.025$	$322.070 \pm 0.025$	$86.50 \pm 0.01$	$89.1 \pm 0.1$

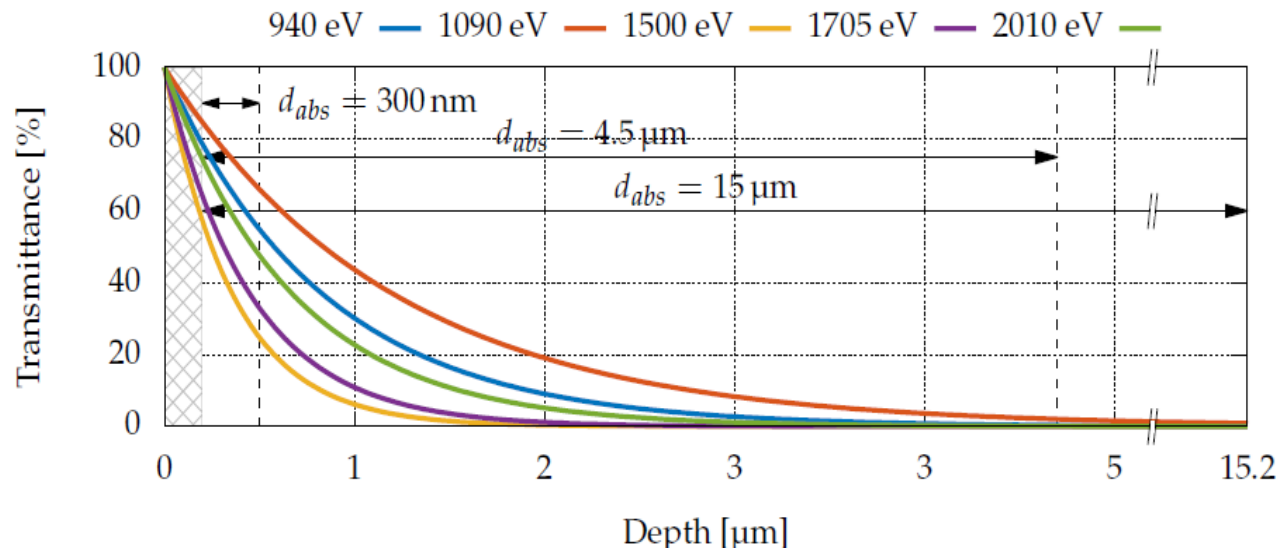
measured and theoretical transmissions have a similar trend and their values are comparable



traps and defects at the interface have a small effect in the charge loss

# Recombination in absorption region (1)

- 5 energies (940 eV, 1090 eV, 1500 eV, 1705 eV, 2010 eV)



transmittance as a function of depth  
 ↓  
 carriers produced at different distances from the multiplication layer

- measurements on 4.5 and 15 μm-thick devices only
- expected current

$$I_{th}(E_{ph}) = \Phi_0 \cdot \frac{E_{ph}}{E_{e-h}} \cdot q,$$

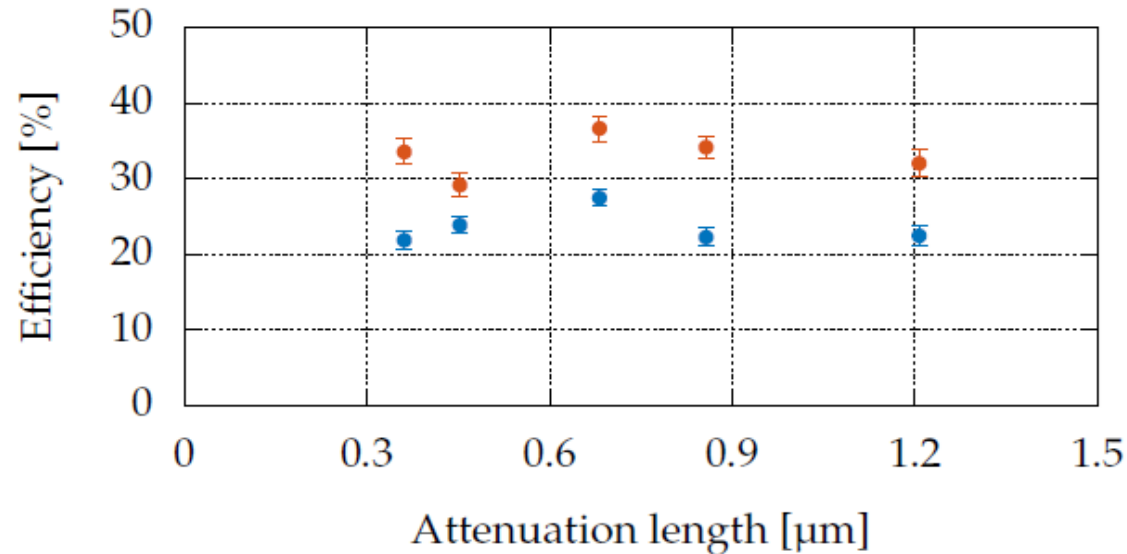
$\Phi_0$ : photon flux [photons/s]

$E_{ph}$ : photon energy [eV]

$E_{e-h}$ : average energy to produce e-h



# Recombination in absorption region (2)



- no dependence on the attenuation length -> negligible recombination during electron travelling through the absorption region
- variations due to systematic error (reposition of the sample)

# Conclusion

- GaAs valid alternative to Si, but careful design required for noise reduction
- ENF can be greatly reduced by band-gap engineering
- negligible effect in charge collection efficiency of:
  - recombination in metal-semiconductor interface
  - recombination in absorption region







Thank you for your attention